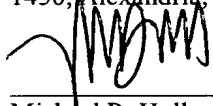


PATENT
29936/39477

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Won Kwon Lee
Serial No.: 10/622,532
Filed: July 18, 2003
For: Method of Forming Isolation
Films in Semiconductor Devices
Group Art Unit: 1765
Examiner: To be assigned

) I hereby certify that this paper and the
) documents referred to as enclosed
) therewith are being deposited with the
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) mail, postage prepaid, on **November 6,**
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) Commissioner for Patents, P.O. Box
) 1450, Alexandria, Virginia 22313-1450

) 
) _____
) Michael R. Hull
) Reg. No. 35,902
) Attorney for Applicants
)
)
)

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

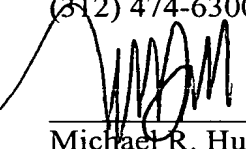
Applicants request the issuance of a corrected filing receipt. A copy of the official filing receipt issued by the U.S. Patent and Trademark Office is enclosed with the following correction noted in red: the claim for priority for Korean Application No. 2002-65753 filed October 28, 2002 is missing. Accordingly, applicants respectfully request the issuance of a corrected filing receipt in connection with this application.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP
6300 Sears Tower
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November 6, 2003

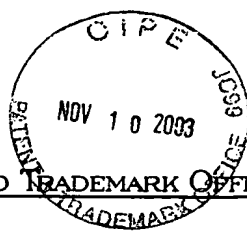
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10/622,532	07/18/2003	1765	750	29936/39477	8	18	3

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MARSHALL GERSTEIN

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FILING RECEIPT



OC000000011077201

Date Mailed: 10/22/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Won Kwon Lee, Chungjoo-Shi, KOREA, REPUBLIC OF; ✓

Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2002-84281 12/26/2002 ✓

REPUBLIC OF KOREA 2002-65754 10/28/2002 ✓

2002-65753 10/28/2002

If Required, Foreign Filing License Granted: 10/21/2003

Projected Publication Date: 04/29/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method of forming isolation films in semiconductor devices ✓

Preliminary Class